



Advanced Mirror Technology Demonstration – 1.5m Pathfinder Mirror

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Advanced UVOIR Mirror Technology Development (AMTD) Program

- Develop mirror blank technology applicable to building a cost effective, large (4m-8m class), passive, monolithic mirror capable of imaging in the UV spectrum
 - 0.43m demonstration mirror fabricated
 - 5.5nm RMS overall surface figure demonstrated
- Current limitations regarding a 4m class mirror
 - Significant mirror depth required to achieve stiffness
 - Core depth drives up cutting costs, schedule, risk, and areal density
 - Stack sealing of boules to achieve overall depth is very expensive and time consuming
- AMTD program addresses these issues to reduce the cost and lead time for building a 4m class mirror blank and demonstrates the ability to polish and test the blank to UV quality



Phase I Review

Developed a 4m design baseline

- > ULE[®] glass
- > 0.4m deep core
 - > Requires 3 boule deep core structure
 - > Developed stacked core, co-fired design to eliminate very deep core cutting
- > Pocketmilled Facesheets
- > Low Temperature Fused and Low Temperature Slumped design

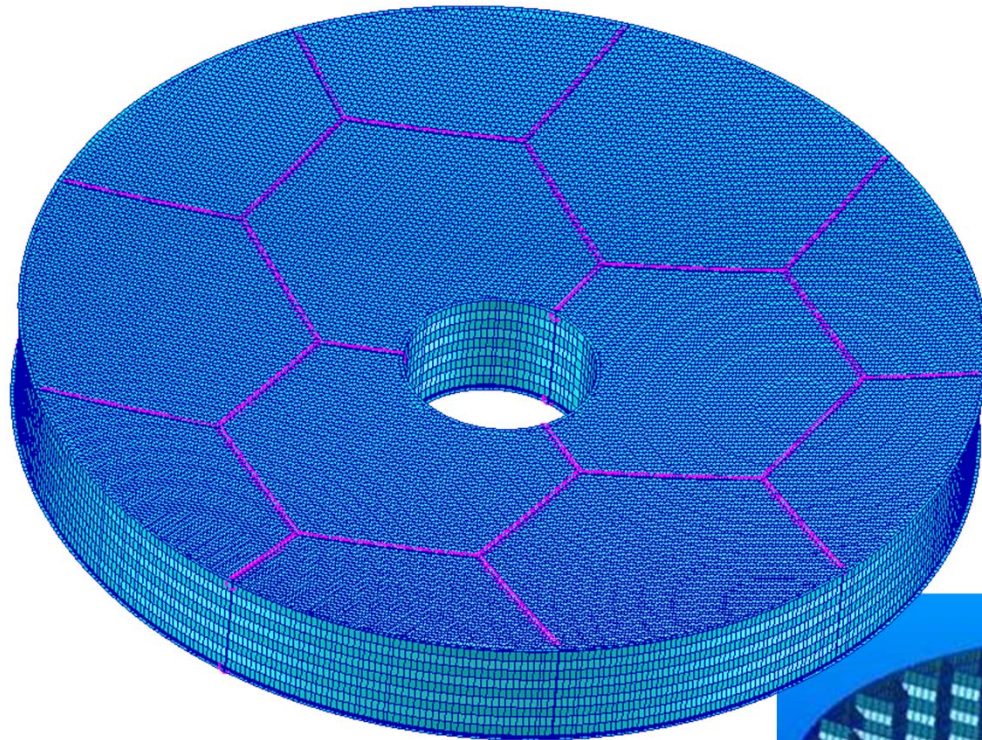
Built and Tested a 0.43 diameter demonstration mirror

- > Polished to 5.5nm RMS which was limited by the repeatability of the V-block mount
- > Tested at MSFC to 250K with no adverse change in surface figure



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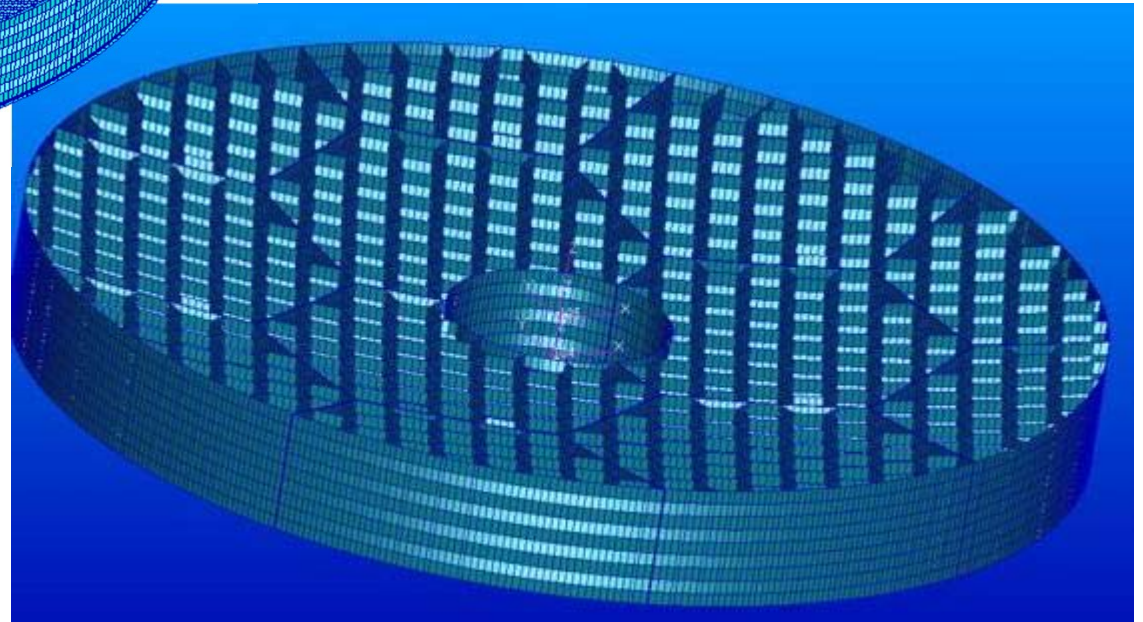
4m Mirror Concept



4m Mirror Physical Attributes

- **Pocket Milled Facesheet** allows larger core cells while controlling quilting
- **12 Core Segments**
- **3 Stacked Core Deep**
- **10m RoC (F#1.25)**

- **Fabrication risk reduced by eliminating stack sealing and deep core cutting**
- **Reduced glass needs for tooling glass**

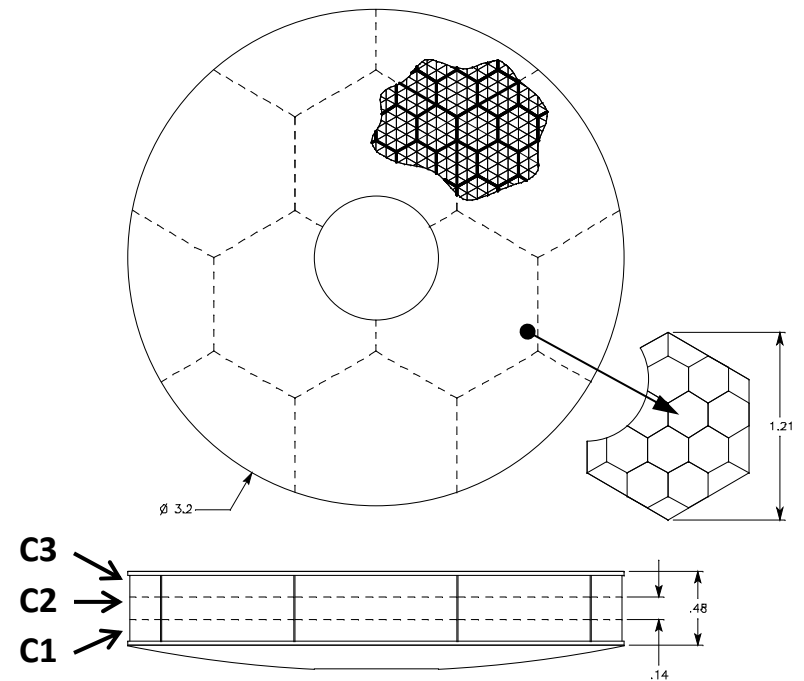
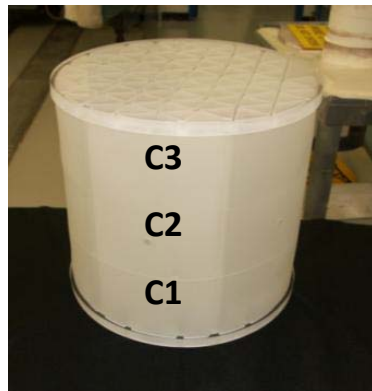


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AMTD is Developing Technologies for Near Term Large Lightweight Primary Mirrors

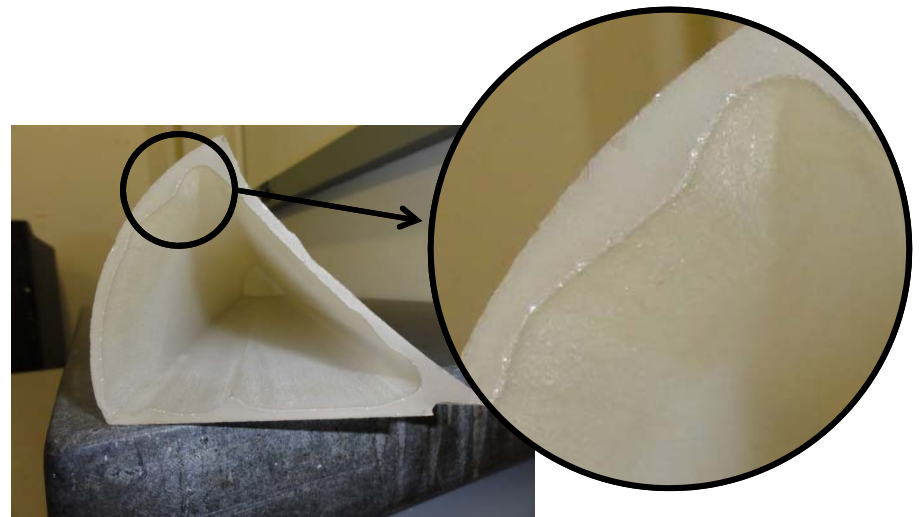
Stacked core

- > Core segments are fabricated from standard thickness boules, then stacked & fused during blank assembly to achieve a deep core
- > Eliminates need for stack sealing of boules and deep AWJ cutting of cores
- > Enables lighter weight cores and reduces cost & schedule for blank fab



Deep AWJ Cutting

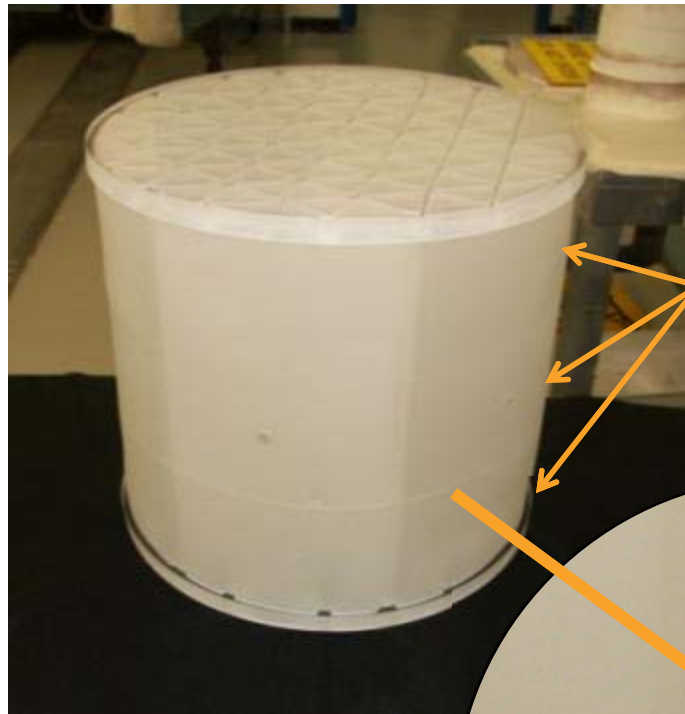
- > Current state-of-the-art AWJ cutting depth for LW cores is ~300mm (12 in)
- > More difficult to control exit surface parameters



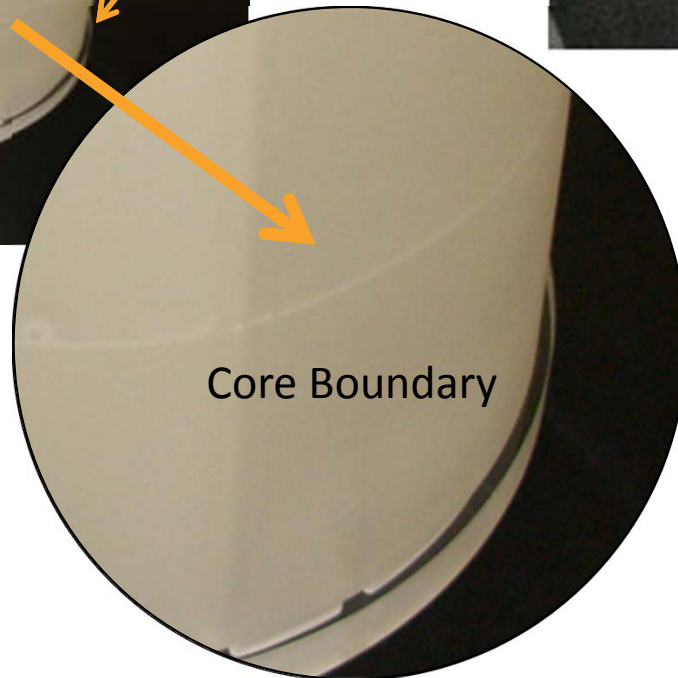
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Stacked Core Mirror Demonstration

0.4m Demonstration part fabricated



Mirror Blank
is 3 cores
high



Single Mirror Core
(Note large cell size)

- The individual core segment surfaces are polished and AWJ just like traditional LTF mirrors
- During Low Temperature Fusion (LTF), the faceplates **and** the core segments are fused together (Co-Fired)



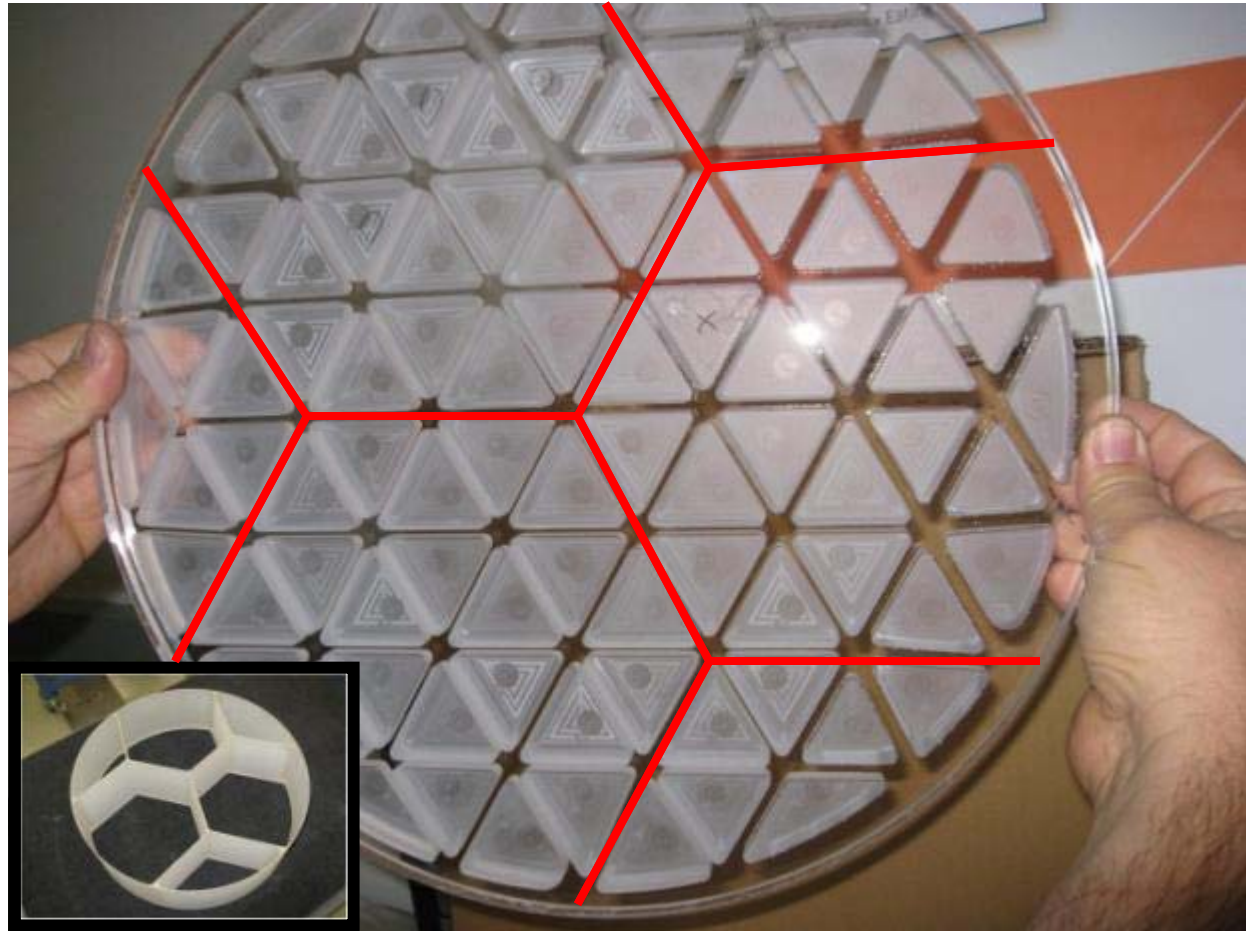
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Faceplate Pocket Milling

- Pocket milled facesheets have been used on other mirrors to provide additional stiffness between cell supports
- Allow for much larger core cell size to reduce overall areal density
- Extended to 24 pockets to enhance UV performance



Pocket Milled Facesheet



Pocket Milled Facesheet
Core cells locations shown in red
(Core shown for reference)



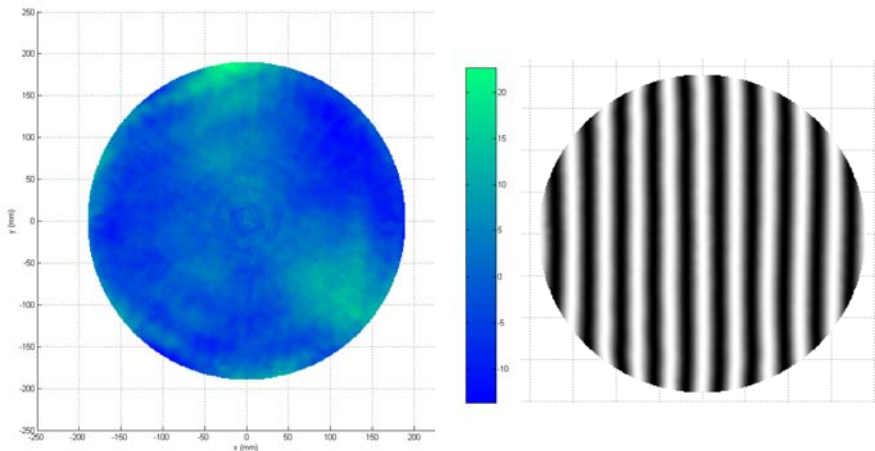
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Processing Quality

Processing completed to demonstrate that UV quality (5nm RMS) could be achieved

Multiple orientation test minimized test errors and analytical backouts

- > Some minimal trefoil did not cancel out during testing
- > Mount repeatability ultimately limited final performance



Final Optical Test – 5.5nm RMS



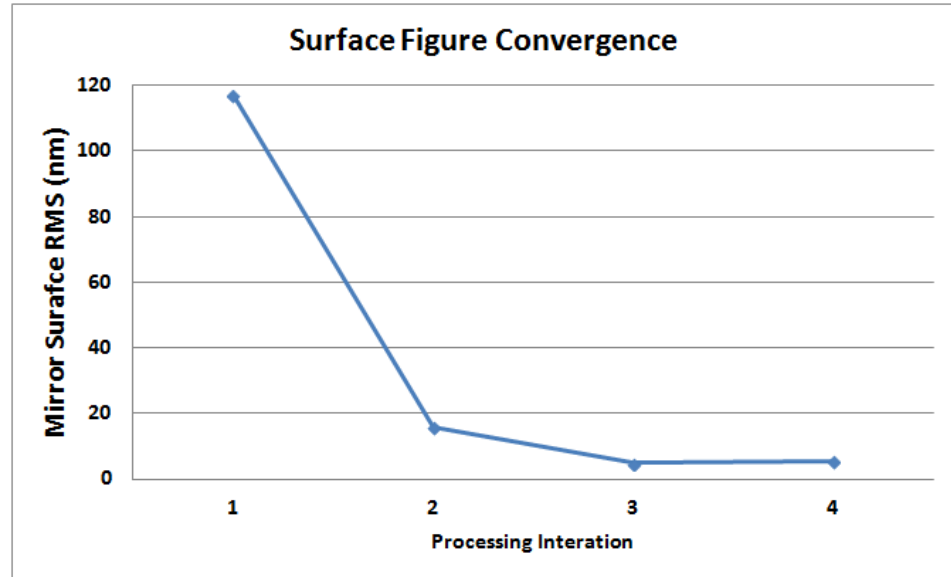
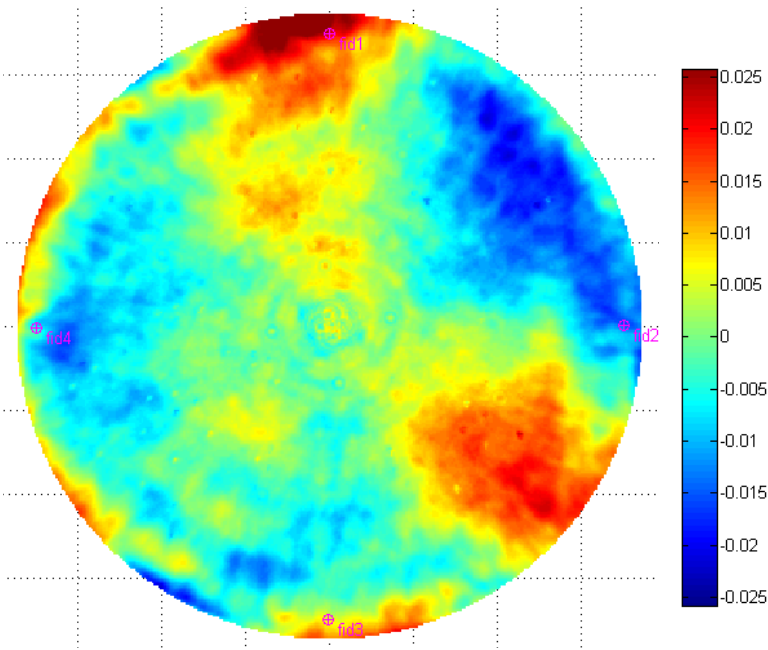
Demo Part in V-Block for Horizontal Testing



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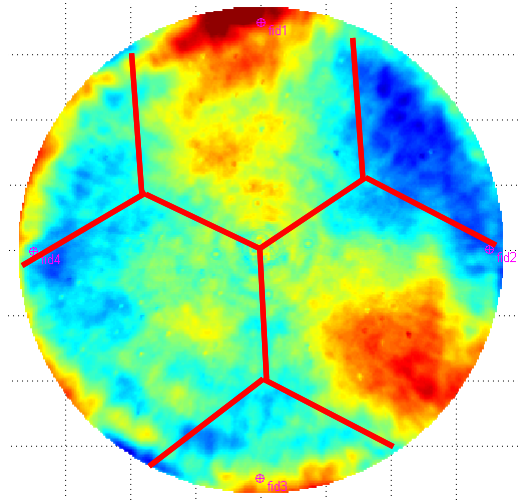
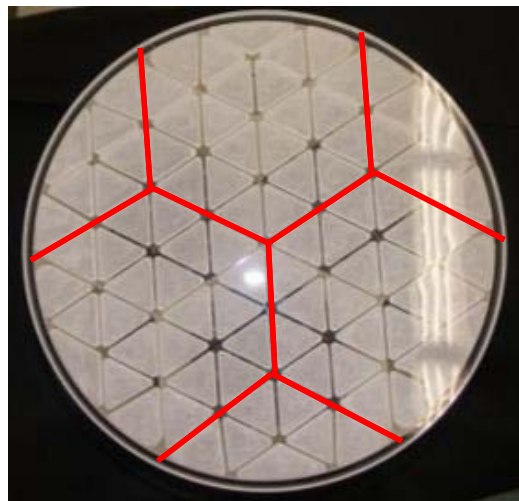
Post Ion Figuring #3

5.4nm RMS – 37nm P-V
Power Removed



- Final ion figuring run focused on pocket quilting errors
- Mount repeatability limits overall surface quality

- Rapid convergence to final surface quality
- Deterministic processes reduce schedule time



Phase II Program

Build and test a Pathfinder Mirror

- > 1.5m on-axis design provides a scalable article that can replicate the performance of the larger 4m design concept
- > 1.5m design is based on Phase I experience and further analysis of 4m design and manufacturing parameters

Pathfinder mirror design nearing completion

- > Replicates the expected 4m design performance
- > Demonstrates scale up of enabling technologies
- > Not optimized for a 1.5m mirror

Advances technology to TRL6



1.5m Design

Design is optimized to best replicate the performance parameters of the much larger 4m mirror while maintaining representative aspect ratios

- > Design is not optimized for a 1.5m mirror

Production of the baseline design will demonstrate scalability of enabling technologies

- > Cores stacked three high and co-fired during LTF
- > Low Temperature Fusion (LTF) of mirror blank
- > Low Temperature Slumping (LTS)

Trade study completed evaluating pocket milling advantages and risk



1.5m LTF/LTS Stacked Core Initial Concept Design

Core Layout Design Constraints

- > The core OD and core ID were developed based on a first order LTS analysis of a previous Exelis FRIT 1.5m PM design assuming 200mm deep core
- > Segment gap based on heritage segmented core designs

Given above constraints, there are only 2 credible cell sizes for consideration that layout well within a core segment petal

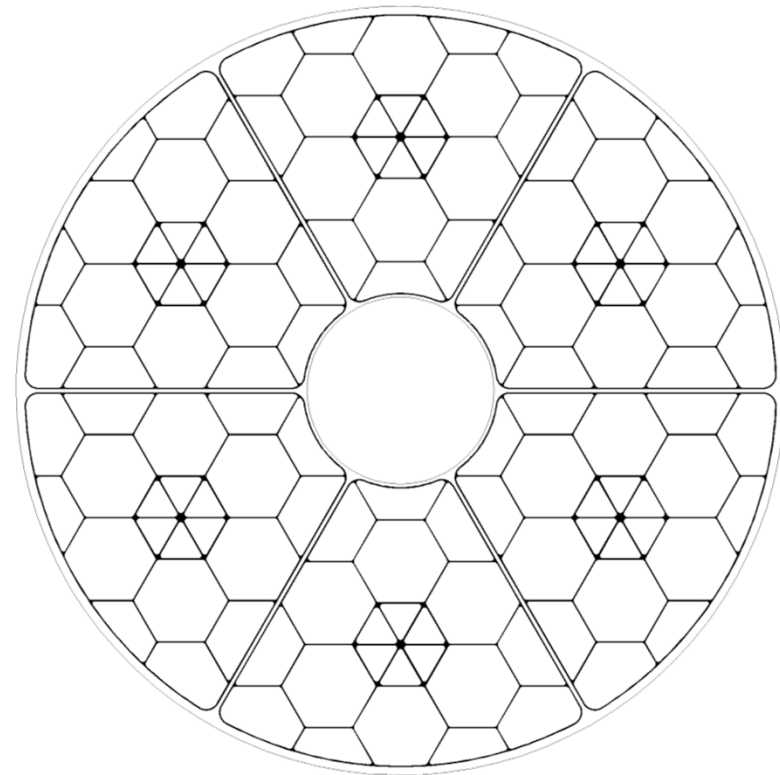
- > 169.3mm (6.665")
- > 191.8mm (7.5525")

Layout using 169.3mm cell is preferred based on performance

- > Lower areal density
- > Smaller mount pads
- > Mount pad location after slumping closer to 0.7X radius

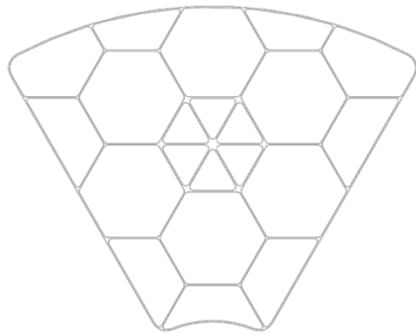
Cell size may be modified in future

- > If an updated LTS analysis indicates that the O.D. of the plano blank needs to change to meet finished O.D. requirements

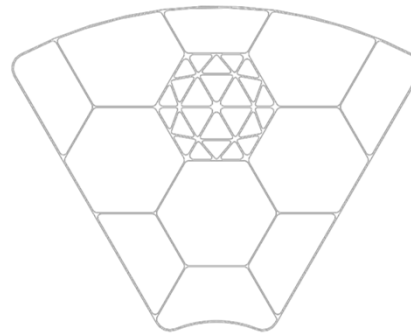


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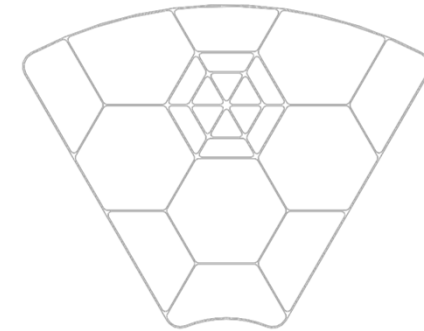
Other 1.5m mirror core layouts were considered



Baseline
(Concept 2)



Concept 3



Concept 4

Baseline concept provides the best compromise between
mount stress control and cell size



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Pocket Milling Trade Results

Pocket Milled vs non-Pocket Milled Faceplates have been traded for years at Exelis

<p><u>Pocket Milled Pro's</u> Less Faceplate Mass Slightly Lower Areal Density Less Uncorrected Gravity Quilting</p>	<p><u>Pocket Milled Con's</u> Longer Schedule Higher Risk Ion Figure Final Quality Higher Cost</p>
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Cost, Schedule, and Risk play heavily in decision

- > Higher risk of damage of single, monolithic face sheet during a very long machining program

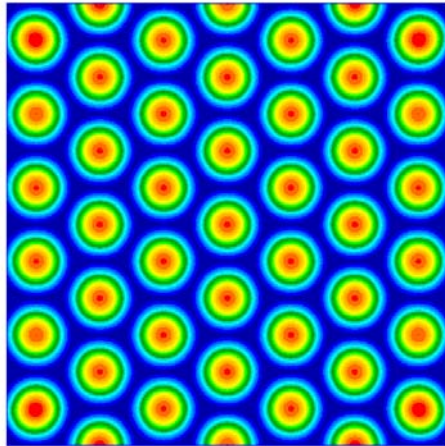
Lower overall areal density of the larger mirror with a pocket milled implementation

Final figure error is actually be better without pocket milling due to larger cores cells that are easier to ion figure

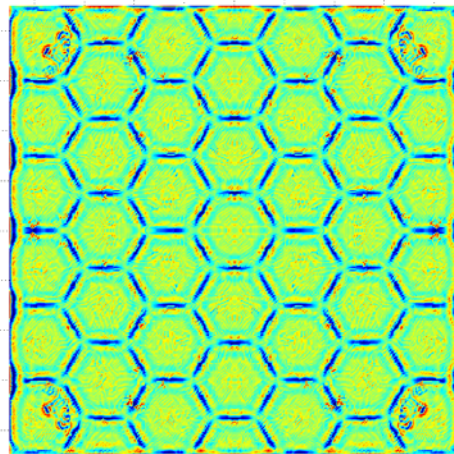
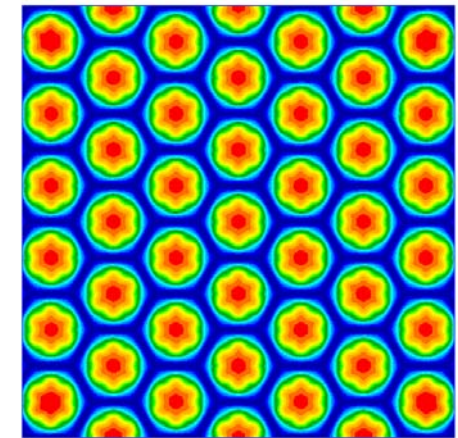
- > At a slight (10%-15%) mass penalty



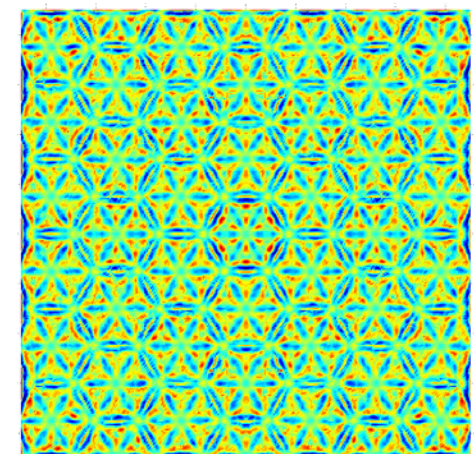
Ion Figuring Analytical Results



Pre-Ion	Infinity-30cm	20cm-2cm	2cm-1.4cm
Non-Pocket	7.5nm	245nm	0.6nm
Pocket	4.6nm	190nm	0.6nm



Pre-Ion	Infinity-30cm	20cm-2cm	2cm-1.4cm
Non-Pocket	0.0nm	0.7nm	0.3nm
Pocket	0.0nm	1.7nm	0.6nm



**Non Pocket Milled
Face Sheets**

Higher frequency errors due to smaller effective cells create larger residual surface error post ion figuring

**Pocket Milled
Face Sheets**

AMTD Phase II Summary

The Phase II Pathfinder mirror is currently in final design

- Draws on experience from Phase I Demo mirror
- Provides traceability to full scale 4m design

Boule glass selection in progress using existing Corning stockpile

- Glass delivery from Corning expected early next year

Blank completion in 2015

All work performed under NASA contract number NNM12AA02C

- COTR: Michael R. Effinger



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